



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov

**\*BIBDATASHEET\*****CONFIRMATION NO. 5700**

Bib Data Sheet

SERIAL NUMBER 10/649,736	FILING DATE 08/28/2003  RULE	CLASS 141	GROUP ART UNIT 3751	ATTORNEY DOCKET NO. 50099-236
-----------------------------	---------------------------------------	--------------	------------------------	-------------------------------------

## APPLICANTS

Yoshiyuki Nakazawa, Kyoto, JP, JAPAN;

## \*\* CONTINUING DATA \*\*\*\*\*

TLM

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN P2002-265323 09/11/2002

TLM

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 11/22/2003

Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JP	SHEETS DRAWING 5	TOTAL CLAIMS 13	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials		

## ADDRESS

MCDERMOTT, WILL & EMERY  
 600 13th Street, N.W.  
 Washington, DC  
 20005-3096

## TITLE

Substrate holding device, substrate processing apparatus, and method of releasing substrate

FILING FEE  RECEIVED 750	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees ( Filing )
		<input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
		<input type="checkbox"/> 1.18 Fees ( Issue )
		<input type="checkbox"/> Other _____
		<input type="checkbox"/> Credit